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Serial Number: 10/065,963

In re application of: Lercel et al.


Before the Examiner: Mohamedulla, Saleha R.

Serial No.: 10/065,963

Group Art Unit: 1756

Filed: 12/04/2002

Confirmation No.: 2539

Title: PATTERN COMPENSATION
TECHNIQUES FOR CHARGED
PARTICLE LITHOGRAPHIC MASKSIntellectual Property Law Department
International Business Machines Corporation
1000 River Street, Internal Zip 972E
Essex Junction, VT 05452**CERTIFICATE OF MAILING OR FAXING**I, hereby, certify that on 10/03/2005, this correspondence is being sent by:☐ Mail - deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, Washington, DC 20231.☒ Facsimile - transmitted by facsimile to the United States Patent and Trademark Office.Name: C. MUELLERSignature: Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

AMENDMENT UNDER 37 CFR 1.111

Responsive to the Office Action of 06/03/2005, the period of response thereto set to expire on 09/03 2005, with a one month extension of time to 10/03/2005, reconsideration of the action and allowance of the present application are respectfully requested, and are believed to be appropriate in view of the following amendments and remarks. Please charge any fees that may be incurred to the deposit account 09-0456.

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